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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/665,910	09/18/2003	Kazue Kudo	16869G-087100US	7077
20350 7	590 09/07/2004		EXAM	INER
	AND TOWNSEND AN	UHLIR, N	UHLIR, NIKOLAS J	
TWO EMBAR	CADERO CENTER			
EIGHTH FLOOR SAN FRANCISCO, CA 94111-3834			ART UNIT	PAPER NUMBER
			1773	

DATE MAILED: 09/07/2004

Please find below and/or attached an Office communication concerning this application or proceeding.

· · · ·	Application No.	Applicant(s)
	10/665,910	KUDO ET AL.
Office Action Summary	Examiner	Art Unit
	Nikolas J. Uhlir	1773
The MAILING DATE of this communication appeared for Reply	ears on the cover sheet with the c	orrespondence address -
A SHORTENED STATUTORY PERIOD FOR REPLY THE MAILING DATE OF THIS COMMUNICATION.  - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication.  - If the period for reply specified above is less than thirty (30) days, a reply If NO period for reply is specified above, the maximum statutory period with a Failure to reply within the set or extended period for reply will, by statute, any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	6(a). In no event, however, may a reply be time within the statutory minimum of thirty (30) days ill apply and will expire SIX (6) MONTHS from cause the application to become ABANDONEI	nely filed s will be considered timely. the mailing date of this communication. D (35 U.S.C. § 133).
Status		
1) ☐ Responsive to communication(s) filed on	action is non-final. ce except for formal matters, pro	
Disposition of Claims		
<ul> <li>4) ☐ Claim(s) 1-5 is/are pending in the application.</li> <li>4a) Of the above claim(s) is/are withdraw</li> <li>5) ☐ Claim(s) is/are allowed.</li> <li>6) ☐ Claim(s) 1-5 is/are rejected.</li> <li>7) ☐ Claim(s) is/are objected to.</li> <li>8) ☐ Claim(s) are subject to restriction and/or</li> </ul>		
Application Papers		
9) The specification is objected to by the Examiner 10) The drawing(s) filed on 18 September 2003 is/an Applicant may not request that any objection to the d Replacement drawing sheet(s) including the correction 11) The oath or declaration is objected to by the Examiner 11.	re: a) accepted or b) object rawing(s) be held in abeyance. See on is required if the drawing(s) is obj	ected to. See 37 CFR 1.121(d).
Priority under 35 U.S.C. § 119		
<ul> <li>12) Acknowledgment is made of a claim for foreign part a) □ All b) □ Some * c) □ None of:</li> <li>1. □ Certified copies of the priority documents</li> <li>2. □ Certified copies of the priority documents</li> <li>3. □ Copies of the certified copies of the priority application from the International Bureau</li> <li>* See the attached detailed Office action for a list of</li> </ul>	have been received. have been received in Application ty documents have been receive (PCT Rule 17.2(a)).	on No d in this National Stage
Attachment(s)		
Notice of References Cited (PTO-892)  Notice of Draftsperson's Patent Drawing Review (PTO-948)  Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08)  Paper No(s)/Mail Date 09/18/2003.	4) Interview Summary ( Paper No(s)/Mail Date 5) Notice of Informal Pa 6) Other:	•

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#### **DETAILED ACTION**

### **Priority**

1. Acknowledgment is made of applicant's claim for foreign priority based on an application filed in Japan on 11/01/02. It is noted, however, that applicant has not filed a certified copy of the Japanese application as required by 35 U.S.C. 119(b).

#### Information Disclosure Statement

2. Applicant's information disclosure statement dated 09/18/03 has been considered. A signed and initial copy of this document accompanies this office action.

## Claim Rejections - 35 USC § 103

- 3. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
  - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 4. Claims 1-5 are rejected under 35 U.S.C. 103(a) as being unpatentable over Ohashi et al. (US6507464) in view of Chen et al. (US6776891).
- 5. The limitations "wherein said magnetic layers are plated films" in claim 1, "wherein said magnetic layers are formed via electroplating in a plating bath having a pH value of 2 or less" in claim 2, "wherein the magnetic layers are formed in a plating bath containing saccharin sodium as a stress relaxing agent," in claim 3, "wherein the plating bath contains sodium saccharin in an amount of 0.5-2g/L," in claim 4, and "the magnetic films are plated films," and "the plated magnetic film is a soft magnetic thin film formed by electroplating in a plating bath having a pH value of 2 or less" in claim 5

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are process limitations in a product claim and do not appear to be further limiting in so far as the structure of the product is concerned. Even though product claims are limited by and defined by the process, determination of patentability is based on the product itself. The patentability of a product does not depend on its method of production. If the product in the claim is the same as or obvious from a product of the prior art, the claim is unpatentable even though the prior product was made by a different process. *In re Thorpe*, 777 F.2d 695, 698, 227 USPQ 964, 966 (Fed. Cir. 1985). See MPEP § 2113.

- 6. Regarding claim 1, Ohashi discloses a thin film magnetic head comprising an inductive head and a magnetoresistive head. The inductive head comprises a lower magnetic pole (2), a gap layer 4, and an upper magnetic pole (1) (column lines 49-55) The magnetoresistive head comprises a lower shielding layer (6), an insulating layer (8), a magnetoresistive element (7), and an upper shielding layer (5) (column 3, lines 55-65). Exact position of the components of the inductive and magnetoresistive heads is shown in figure 1 of the reference and so will not be described here. It is the examiners position that the head disclosed by Ohashi corresponds to a thin film magnetic head having multiple magnetic layers.
- 7. Ohashi discloses that at least one of the poles in the inductive head is preferably formed of a CoFeNi soft magnetic film (column 3, lines 8-15). The saturation magnetization of the CoFeNi thin films is disclosed to be in the range of 20-23kg (column 3, lines 49-53). While Ohashi does not teach the CoFeNi that meets the saturation magnetization or composition limitations required by the instant claims.

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Ohashi does teach that magnetic materials with higher saturation magnetization are needed so as to enable magnetic recording heads to record on magnetic materials with high anisotropy energy (column 2, lines 32-46).

- 8. Bearing the above in mind, Chen teaches a method for manufacturing ultra high saturation magnetic moment soft magnetic films, wherein said soft magnetic films are suitable for use in the fabrication of magnetic write heads for high density recording media (title and column 3, lines 5-10). In particular, Chen teaches the formation of a Co<sub>100-a-b</sub>Fe<sub>a</sub>M<sub>b</sub> film, where M can be Ni and wherein a is 63-67 wt% and B is 0-0.5 wt% (column 3, lines 53-58). Though the process limitations of the instant claims are not deemed by the examiner to further limit the claims, the examiner notes that Chen electroplates these films from a plating bath that can contain sodium saccharin as a stress reducing agent (column 4, lines 29-50). The pH of the bath is in the range of 2-4 (column 5 table). Thus, the process of Chen is substantially the same as that disclosed by the applicant.
- 9. Therefore it would have been obvious to one of ordinary skill in the art at the time the invention was made to substitute the Co<sub>100-a-b</sub>Fe<sub>a</sub>Ni<sub>b</sub> (where a is 63-67 and b is 0-0.5) soft magnetic film taught by Chen for the CoFeNi film utilized in the inductive write head taught by Ohashi.
- 10. One would have been motivated to make this modification in view of the fact that the CoFeNi thin film taught by Chen has a higher magnetization than that disclosed by Ohzaki, and is specifically disclosed to be useable in magnetic write heads for high density recording media. This would especially motivate one of ordinary skill in the art in

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view of the teaching in Ohashi that higher saturation magnetization materials are desirable because they can record on media that have higher recording density and higher magnetic anisotropy energy.

11. Claims 2-5 are met as set forth above. The examiner further notes that the specific concentration of sodium saccharin required by claim 4 is disclosed in table 2 of the Chen reference ( $C_7H_5NO_3S$  is the anion of sodium saccharin).

#### Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Nikolas J. Uhlir whose telephone number is 571-272-1517. The examiner can normally be reached on Mon-Fri 7:30 am - 5 pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Deborah Jones can be reached on 571-272-1535. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

MJU Nju D. S. NAKARANI PRIMARY EXAMINER